

Two-dimensional type-II $\text{XSi}_2\text{P}_4/\text{MoTe}_2$ ($\text{X}=\text{Mo}, \text{W}$) van der Waals heterostructures with tunable electronic and optical properties

Qingqing Luo^a, Shaoqian Yin^{a,*}, Xiaoxin Sun^a, Yanan Tang^b, Zhen Feng^c, and Xianqi Dai^{a,*}

^a School of Physics, Henan Normal University, Xinxiang, Henan 453007, China.

^b School of Physics and Electronic Engineering, Zhengzhou Normal University, Zhengzhou, Henan 450044, China.

^c School of Materials Science and Engineering, Henan Engineering Research Center for Modification Technology of Metal Materials, Henan Institute of Technology, Xinxiang, Henan 453000, China

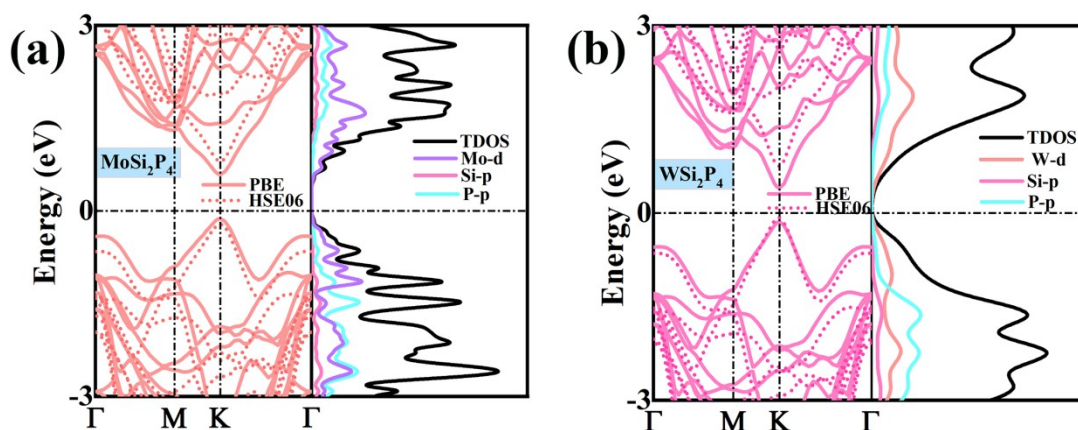


Fig. S1. The band structures and corresponding PDOS for MoSi_2P_4 and WSi_2P_4 monolayers

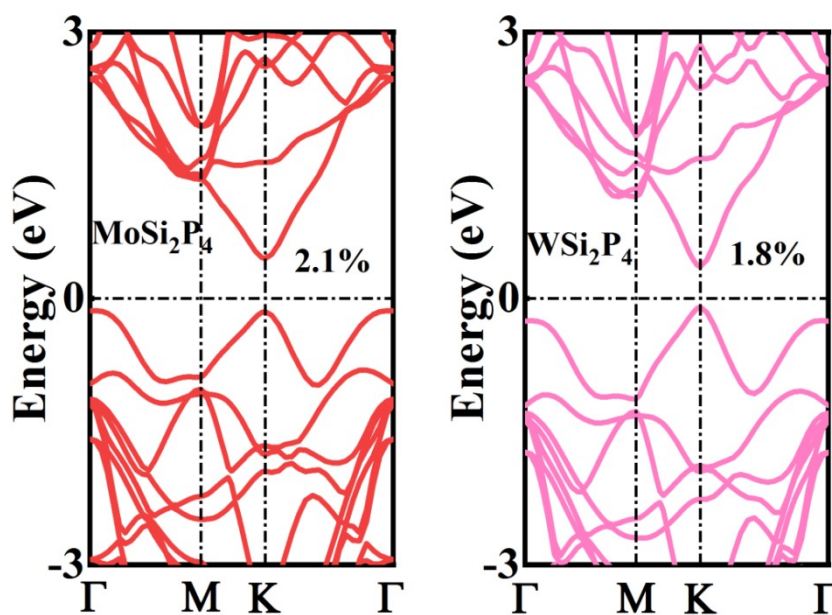


Fig. S2. Calculated the band structures of $\text{MoSi}_2\text{P}_4/\text{WSi}_2\text{P}_4$ under tensile 2.1% /1.8%

* Address correspondence to E-mail: ysq@htu.edu.cn (Shaoqian Yin), xqdai@htu.edu.cn (Xianqi Dai)

Table S1

Calculated the binding energy E_b (eV) and cohesive energy E_{coh} (eV) of different models for the $\text{MoSi}_2\text{P}_4/\text{MoTe}_2$ and $\text{WSi}_2\text{P}_4/\text{MoTe}_2$ heterostructures

	A1	A2	A3	A4	A5
E_b (eV)	-0.254	-0.241	-0.177	-0.173	-0.270
E_{coh} (eV)	-5.512	-5.511	-5.504	-5.504	-5.514
	B1	B2	B3	B4	B5
E_b (eV)	-0.298	-0.218	-0.218	-0.220	-0.361
E_{coh} (eV)	-4.766	-4.758	-4.758	-4.756	-4.767

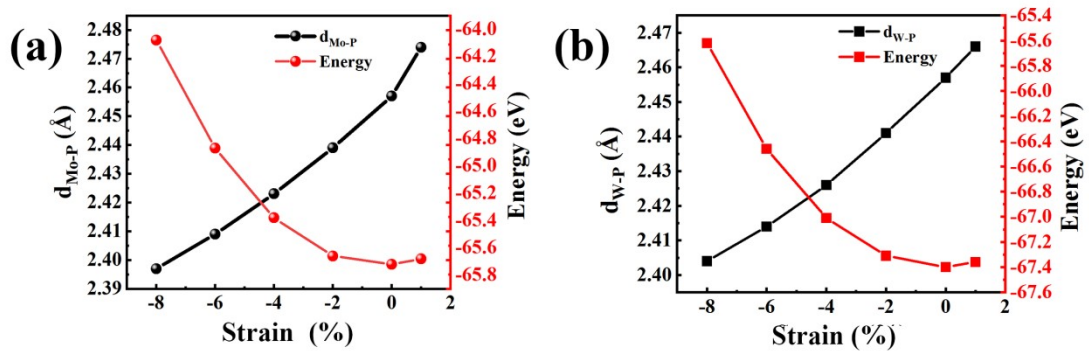


Fig. S3. The bond lengths ($d_{\text{Mo-P}}$ and $d_{\text{W-P}}$) and total energies under different strains for the (a) $\text{MoSi}_2\text{P}_4/\text{WSi}_2\text{P}_4$ and (b) $\text{WSi}_2\text{P}_4/\text{WSi}_2\text{P}_4$ heterostructures.

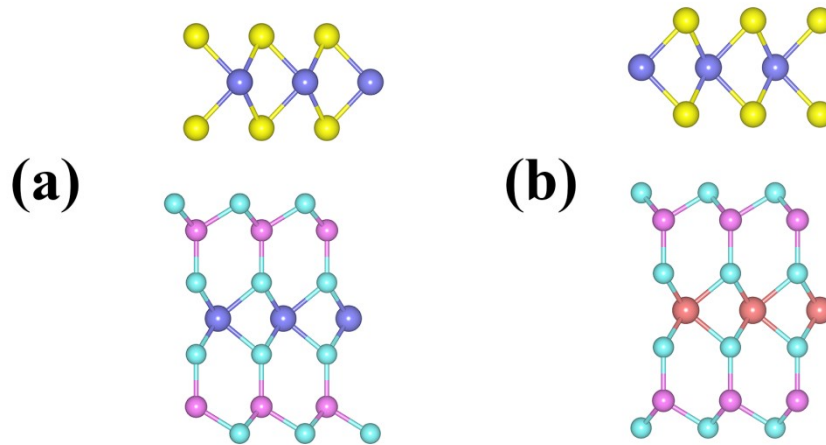


Fig. S4. The optimized structures of (a) $\text{MoSi}_2\text{P}_4/\text{MoTe}_2$ heterostructure and (b) $\text{WSi}_2\text{P}_4/\text{MoTe}_2$ heterostructure under biaxial strain $\epsilon = -9\%$. (Where the purple, watermelon red, pink, cyan and yellow spheres represent the Mo, W, Si, P and Se elements, respectively).

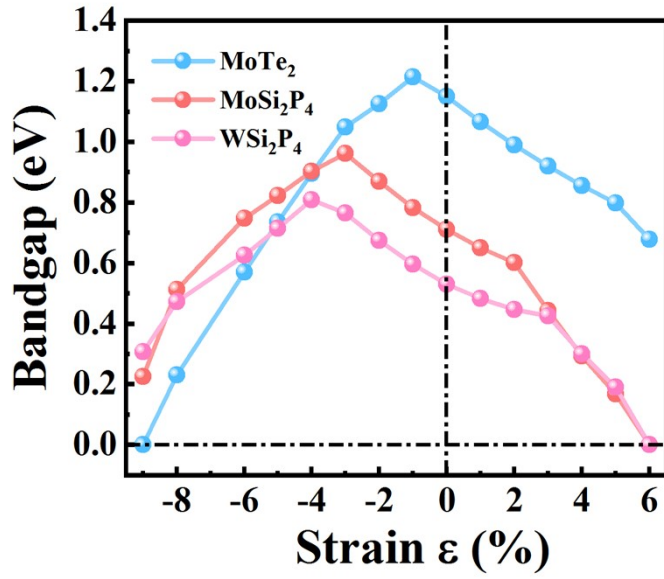


Fig. S5. The bandgap as of MoSi₂P₄, WSi₂P₄ and MoTe₂ as functions with various biaxial strains

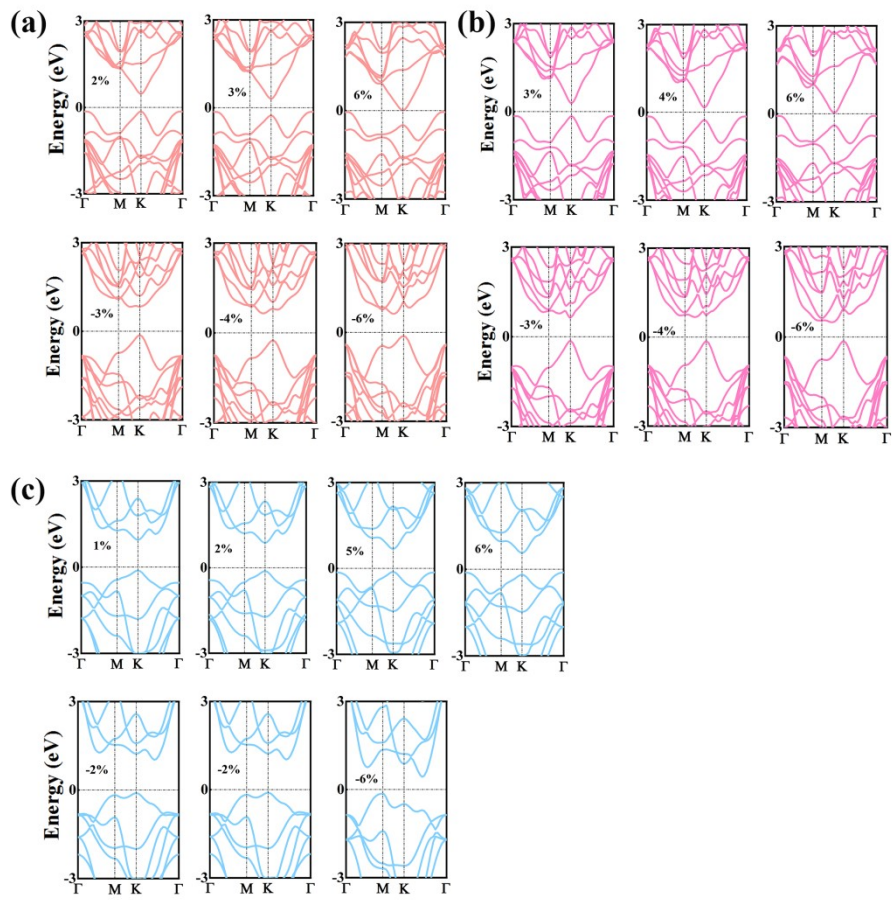


Fig. S6. The band structures of (a) MoSi_2P_4 , (b) WSi_2P_4 and (c) MoTe_2 under different strains

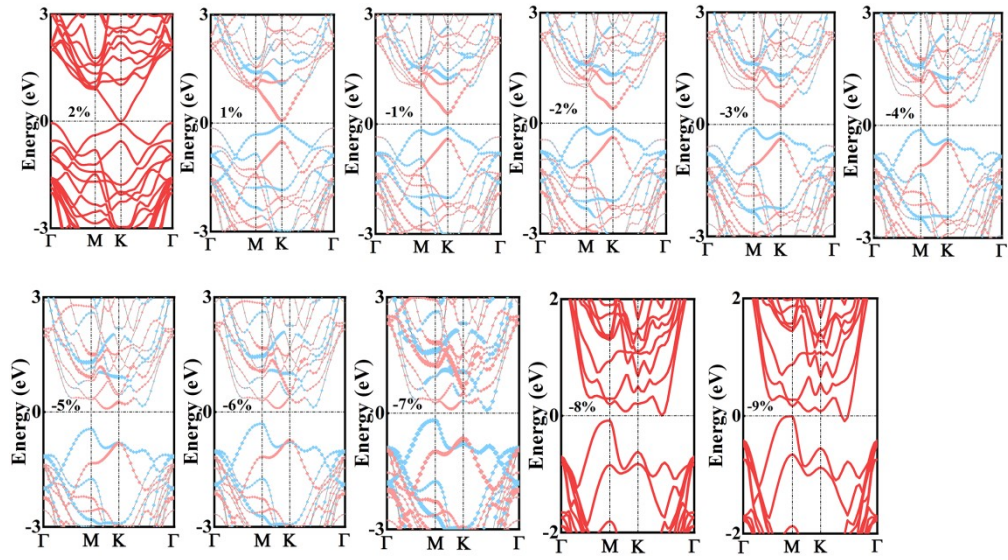


Fig. S7. The projected band structures of the $\text{MoSi}_2\text{P}_4/\text{MoTe}_2$ vdWHs under different biaxial strains

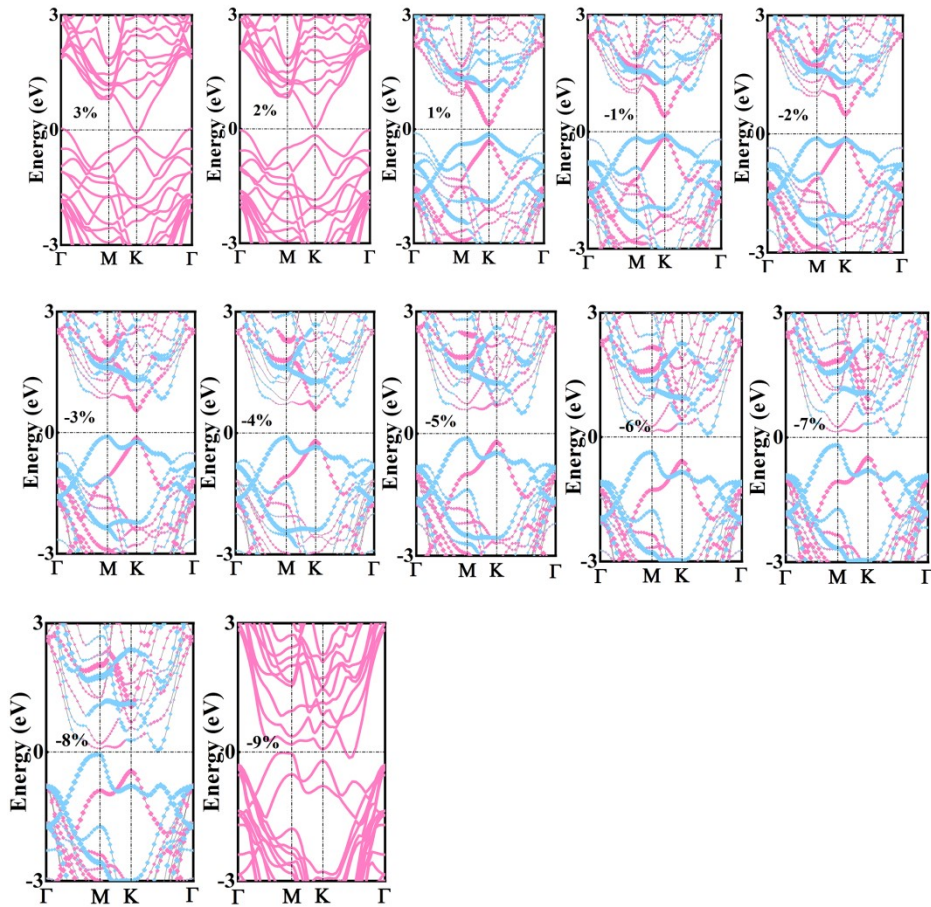


Fig. S8. The projected band structures of the $\text{WSi}_2\text{P}_4/\text{MoTe}_2$ vdWHs under different biaxial strains

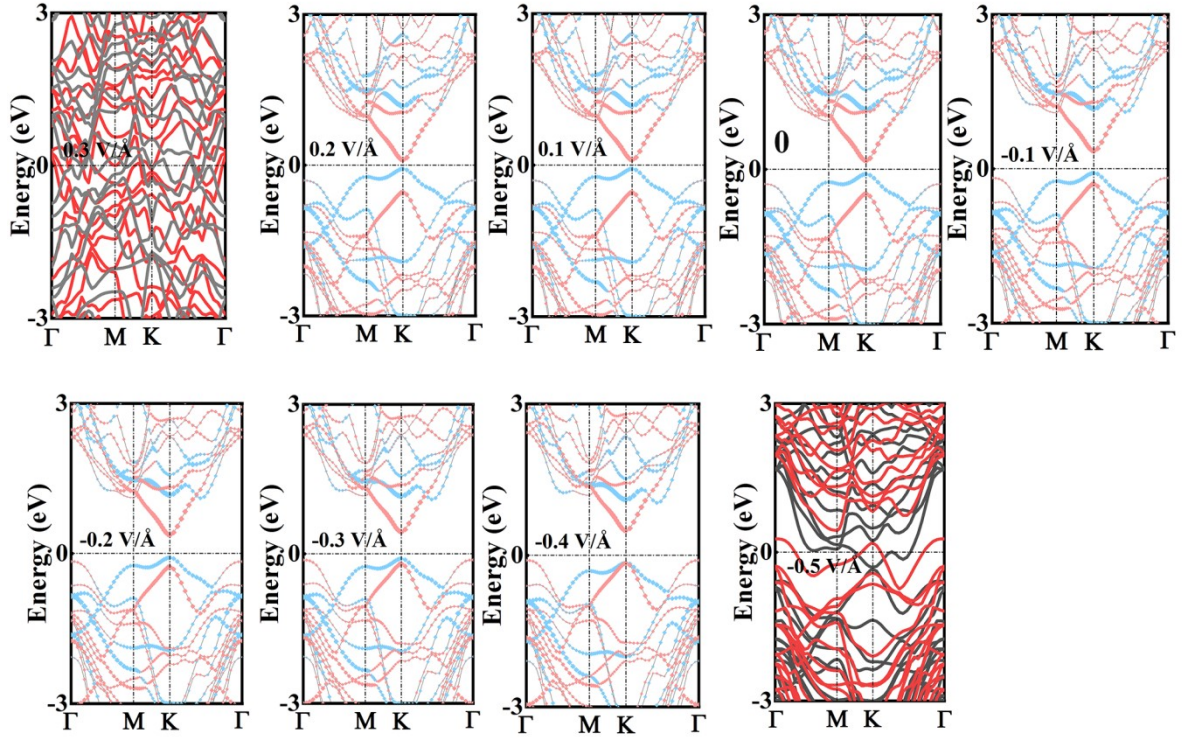


Fig. S9. The projected band structures of the MoSi₂P₄/MoTe₂ vdWHs under different external electric fields

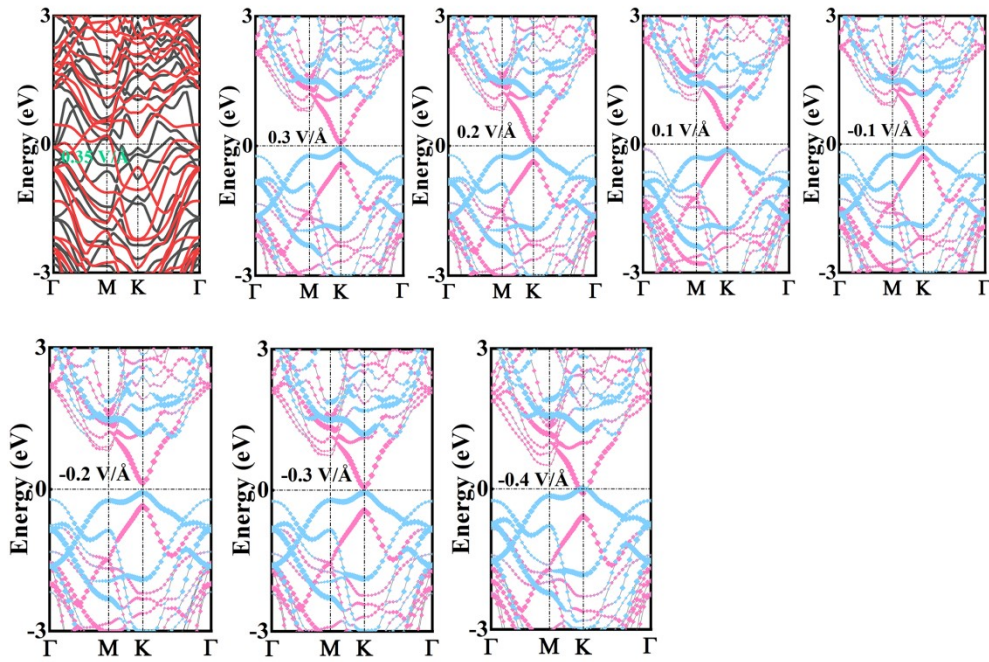


Fig. S10. The projected band structures of the WSi₂P₄/MoTe₂ vdWHs under different external electric fields